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| Notice of References Cited | Application/Control No. 10/781,786 | Applicant(s)/Patent Under Reexamination HIGASHI, MITSUTOSHI | |
| | Examiner Larisa Z Tsukerman | Art Unit 2833 | Page 1 of 1 |

U.S. PATENT DOCUMENTS

| * | | Document Number Country Code-Number-Kind Code | Date MM-YYYY | Name | Classification |
|---|---|--|-----------------|-------------------------|----------------|
| * | A | US-6,439,898 | 08-2002 | Chua et al. | 439/81 |
| | B | US-6,183,267 | 02-2001 | Marcus et al. | 439/66 |
| | C | US-6,442,831 | 09-2002 | Khandros et al. | 29/843 |
| | D | US-6,168,974 | 01-2001 | Chang et al. | 438/109 |
| | E | US-6,469,386 | 10-2002 | Lee et al. | 257/748 |
| | F | US-3,576,415 | 04-1971 | Gwyn, Jr., Childress B. | 200/269 |
| | G | US-4,374,311 | 02-1983 | Okahashi et al. | 200/269 |
| | H | US-6,770,383 | 08-2004 | Tanaka et al. | 428/646 |
| | I | US-6,640,432 | 11-2003 | Mathieu et al. | 29/842 |
| | J | US-6,222,377 | 04-2001 | Kato, Masatoshi | 324/754 |
| | K | US-2003/0173107 | 09-2003 | Smith et al. | 174/256 |
| * | L | US-6,029,344 | 02-2000 | Khandros et al. | 29/874 |
| | M | US- | | | |

FOREIGN PATENT DOCUMENTS

| * | | Document Number Country Code-Number-Kind Code | Date MM-YYYY | Country | Name | Classification |
|---|---|--|-----------------|---------|------|----------------|
| | N | | | | | |
| | O | | | | | |
| | P | | | | | |
| | Q | | | | | |
| | R | | | | | |
| | S | | | | | |
| | T | | | | | |

NON-PATENT DOCUMENTS

| * | | Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) |
|---|---|--|
| * | U | Kirt R. Williams, "Jornal of Microelectromechanical Systems, Vol.12, No. 6, December 2003, pages 771-778 |
| | V | |
| | W | |
| | X | |

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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